

Setting the Standard for Automation™

Chemical Microsensor Development for Aerospace Applications

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Standards Certification Education & Training Publishing Conferences & Exhibits

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Chemical Sensor Development at NASA GRC

Microsensors and platforms

- * H₂, CH₄, C₂H₄, C₃H₆, CO₂, CO, O₂, NOx, N₂H₄, HCl, HCN, and HF
- * Schottky diodes, resistors, and electrochemical cells
- Approaches
 - * Smart sensor system: sensor arrays, signal processing and conditioning components, power and telemetry
 - * "Lick and Stick" for full-field view of environment
 - * Nanotechnology and batch microfabrication
 - * Small size, low weight, cost, and power consumption

• Applications

- * Propulsion system, fuel depot leak detection
- * Low false alarm fire detection.
- * Harsh environment engine emissions monitoring
- * Human health monitoring and potential astronaut health evaluation
- Sensor to be presented
 - * CO₂ sensors: Electrochemical cells: amperometric and metal oxide nanomaterial modified, potentiometric sensors and resistors
 - * H_2/C_xH_y Schottky diode sensors: Diodes and diodes with contact pads
 - * O₂ sensors: High temp and room temp
 - * NO sensor: metal oxide resistor based
 - * Metal oxide nanomaterials



NASA GRC Sensors and Electronics Branch cleanroom



NASA GRC



Addition of Tin Oxide Nanocrystallines Improves Solid Electrolyte Carbon Dioxide Sensor Performance

K. Obata et al. / Sensors and Actuators B 76 (2001) 639-643

In2O3

Air + CO2

Au paste

Au wire

Na3PO

 SnO2 Nanocrystallines

 Na2CO3/BaCO3

 NASICON
 Pt(+)

 NASICON
 Pt(-)

 Al2O3

Tin oxide nanocrystalline layer added



Potentiometric CO₂ Microsensors Developed



1%, 2%, 3%, 4% CO2 gases in air at 500°C, air for baseline



$$2\text{Li}^{+} + \text{CO}_{2} + \frac{1}{2}\text{O}_{2} + 2e - = \text{Li}_{2}\text{CO}_{3}$$
 Working
 $2\text{Li}^{+} + \text{TiO}_{2} + \frac{1}{2}\text{O}_{2} + 2e - = \text{Li}_{2}\text{TiO}_{3}$ Reference

Development of Diode Sensors with Contact Pads



А

1.

for

metal/PdO_x/SiC

Fig.

diode

detection.

single

based

 H_2/C_xH_v





Fig. 2. a) Schottky diode with contact pad fabrication process. b). Image of a Pd/PdO_x/SiC diode with a Au/Ti contact pad. The dark area surrounding the sensor-pad is SiO_2











Fig. 5. Sensor with interconnect contact pad response to 0.5% H2 at 500°C, 1V

Fig. 3. Current version of diode with contact pad

Fig 4. a). Sensor with interconnect contact pad responses to 50 ppm, 100 ppm, 150 ppm, and 200 ppm H2 gases; b). Sensor responses to 50 ppm, 25 ppm, and 20 ppm H2 gases, at 300°C, 1V.

Developed Room Temperature Potentiometric Oxygen Sensors

Totally different structure: one of its kind



Time / sec

Development of Nitric Oxide and Oxygen Sensors

Pt interdigitated electrodes fabricated on a 2-inch alumina wafer

Electrode structure and schematic of gas testing setup



High Temperature YSZ Oxygen Sensor Testing Results



Sputtered ITO Microsensor Response to Nitric Oxide Gas 1.86E-02 1.84E-02 450°C, 1V 60 ppm NO 450°C,1V 10 ppm NO 4 ppm NO 40 ppm NO 20 ppm NO 1.84E-02 397 ppb NO 1.82E-02 1.59 ppm NO 159 ppb NO 2.38 ppm NO 794 ppb NO 1.82E-02 1.80E-02 urrent (A) 1.80E-02 N₂/Air 1.78E-02 (60:40) (1. Adsorption) Current (A) 1.78E-02 1.76E-02 1.76E-02 (2. Chemical reaction) ū 1.74E-02 1.74E-02 1.72E-02 1.72E-02 1.70E-02 1.70E-02 N₂/Air (60:40) N₂/Air (60:40) 1.68E-02 1.68E-02 0 10 20 40 50 60 70 80 90 30 10 30 40 0 20 50 60 70 80 Time (min) Time (min)

- * Low concentration (ppb to low ppm): adsorption
- * High concentration (ppm): adsorption and NO oxidation reaction:



Metal Oxide Nanomaterials for Reducing Gas Sensing



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- A variety of chemical microsensors development for aerospace applications
- Different sensor structures and sensing mechanisms were used in the sensor designs
- Carbon dioxide sensors, oxygen sensors, Schottky diode sensors, nitric oxide sensors, and nanomaterials discussed
- Small size, batch fabrication, low cost and power consumption, and harsh environment applications
- Applications: fire detection, engine emission and health monitoring, and environmental monitoring. In ambient and harsh environments



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NASA Aviation Safety Program/IVHM Project NASA ETDP/Space Fire Prevention Task